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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application Serial No. .... 09/652,533  
Filing Date ..... August 31, 2000  
Inventor..... Gurtej S. Sandhu et al  
Assignee..... Micron Technology, Inc.  
Group Art Unit..... 2823  
Examiner ..... W. Brewster  
Attorney's Docket No. .... MI22-1385  
Title: Deposition Methods and Apparatuses Providing Surface Activation

**RESPONSE TO MARCH 21, 2003 OFFICE ACTION**

To: MS Non Fee Amendment  
Commissioner for Patents  
Art Unit 2823  
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Arlington, VA 22313-1450

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**AMENDMENTS**

**Introductory Comments**

The present Response is submitted in the Revised Amendment Format and therefore qualifies for waiver of provisions 37 CFR §§1.121(a), (b), (c) and (d).

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JUN 30 2003  
TECHNOLOGY CENTER 2800

EV317135915